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CONFIRMATION NO. 8788

Taro Ikeda, Nirasaki-Shi, JAPAN; *** CONTINUING DATA ******* This application is a CIP of PCT/JP02/01111 02/08/2002 *** FOREIGN APPLICATIONS*** JAPAN 2001-032711 02/08/2001 IF REQUIRED, FOREIGN FILING LICENSE GRANTED *** 11/03/2003 Foreign Priority claimed					
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